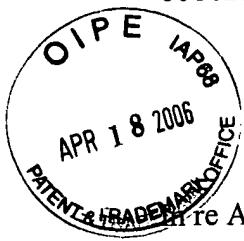


00862.102566.

PATENT APPLICATION

IFW



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Re Application of: )  
KIYOFUMI SAKAGUCHI, ET AL. )  
Application No.: 10/540,263 )  
Filed: June 23, 2005 )  
For: SEMICONDUCTOR SUBSTRATE, )  
MANUFACTURING METHOD )  
THEREOF, AND )  
SEMICONDUCTOR DEVICE : April 17, 2006  
: Examiner: Eduardo A. Rodela  
: Group Art Unit: 2826

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

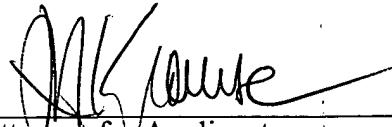
RESPONSE TO RESTRICTION REQUIREMENT

Sir:

In response to the Office Action dated March 28, 2005, Applicants provisionally elect the claims of Group II for initial prosecution on the merits; namely,  
Claims 3-18.

Applicant's undersigned attorney may be reached in our New York office by telephone at (212) 218-2100. All correspondence should be directed to our below listed address.

Respectfully submitted,

  
\_\_\_\_\_  
Attorney for Applicants  
John A. Krause  
Registration No. 24,613

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